

RIBER

Press release – New orders
Bezons, France, July 9, 2009; 6.00PM

New orders for the leading player in molecular beam epitaxy

Bezons, France, July 9, 2009 – 5.45 – RIBER, the global leader for molecular beam epitaxy (MBE), announces the signing of several major orders in France, Russia and Asia.

Order of a research machine to INSA Rennes (France)

Riber is pleased to announce the sale of a new research system to the FOTON laboratory of INSA Rennes, France. This acquisition of a gas source silicon epitaxy system, the RIBER LPCVD21 model, was made with the support of French and European PONANT/FEDER funds.

This new machine will be connected to an already installed RIBER Compact21 and will enable the FOTON-INSA laboratory to increase its research capacities on opto-electronic components. The studies relate particularly to light transmitters based on nano-structured III-V semi-conductors (AsGa) on silicon substrates.

The FOTON laboratory has developed significant expertise in the production of opto-electronic components, and as a result is an active participant in international centers of excellence networks in its field of research.

Sales expanding in Russia

At the same time, RIBER received an order for a Compact21 system, to the International Tomographic Center of the Siberian division of the Russian Academy of Science in Novosibirsk (Russia).

The Compact21, the MBE research system the most sold in the world, provides unequalled flexibility. The system acquired by the Russian Academy of Science is dedicated to nano-technology applications on III-V components (AsGa). It will be set up by Dr A. Toropov.

Signing of a major OLED cell order in Asia

In the field of OLEDs (Organic Light Emitting Diodes), RIBER confirms that the sales of evaporation sources is taking off with the signing of a significant order from a major Asian manufacturer. Over the past few years, RIBER has supplied deposition system manufacturers and final users with effusion cells that are suitable for depositing OLED structures on large-size screens.

The OLED flat panels are more environmentally friendly, use less power, their viewing angle is wider and pictures are much brighter. First used in the production of small flat panels (mobile phones, radios, notebooks, etc...) the OLED technology is gradually diversifying with the production of flexible large-size flat panels and planar luminaries.

The diversity of these applications confirms Riber's internationally recognized reputation in vacuum and ultra-vacuum deposition technologies.

Shareholders' agenda:

2009 1st half-year sales: Thursday July 16, 2009 (after close of trading)

About RIBER:

Riber designs and produces molecular beam epitaxy (MBE) systems as well as evaporation sources and cells for the semi-conductor industry. This high-technology equipment is essential for the manufacture of compound semi-conductor materials and new materials that are used in numerous consumer applications such as new Information Technologies, OLED flat screens and the new generation of solar cells.

Riber SA's shares are listed in Compartment "C" of the Euronext Paris Stock Exchange and are a component of the CAC IT index.

ISIN Code: FR0000075954 Reuters Code: RIBE.PA Bloomberg Code: RIB.FP

Riber has been awarded the OSEO innovation certification, enabling it to qualify for FCPIs (French mutual funds).

Your contacts:

RIBER

Olivier HANDSCHUMACHER

Tel: +33 (0)1 39 96 65 00

e-mail: ohandschumacher@riber.fr -

CALYPTUS

Cyril Combe

Tel: +33 (0)1 53 65 68 68

cyril.combe@calyptus.net